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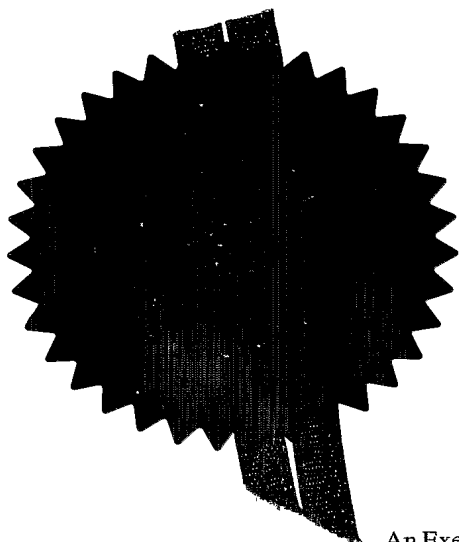
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P01/7700 0.00-0402412.1 ACCOUNT CHA

3. Full name, address and postcode of the or of each applicant (underline all surnames)

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Patents ADP number (if you know it)

If the applicant is a corporate body, give the country/state of its incorporation

United Kingdom

4428439002

4. Title of the invention

TEMPERATURE SENSOR ASSEMBLY

5. Name of your agent (if you have one)

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Patents ADP number (if you know it)

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Number of earlier application

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TEMPERATURE SENSOR ASSEMBLY

This invention relates to a temperature sensor assembly for use with an electrical heating arrangement in a cooking appliance, in which a cooking plate, such as of glass-ceramic material, has an upper surface for receiving a cooking utensil and a lower surface having supported in contact therewith an electric heater incorporating at least one electric heating element.

10

It is known to provide an electrical heating arrangement for a cooking appliance in which a temperature sensing device is arranged under a glass-ceramic cooking plate in order to monitor the temperature of a cavity between a heating element of an electric heater and an underside of the glass-ceramic plate, whereby to monitor the temperature of the glass-ceramic plate and to operate to control energising of the heating element, particularly to ensure that the temperature of the glass-ceramic plate does not exceed a safe limit value. Such a temperature sensing device is known to comprise a temperature-sensitive electrical resistance element supported on a suitable substrate and arranged to be subjected to direct thermal radiation from the heating element.

25



A different requirement relates to the sensing of temperature of a cooking utensil located on the upper surface of a cooking plate, using a temperature sensing device provided underneath the cooking plate. Here it is required to be able to measure small changes in temperature in the cooking plate overlying the temperature sensing device and good thermal coupling is required between the temperature sensing device and the cooking plate. However, if the temperature sensing device also receives direct thermal radiation from the heating element in the underlying heater, this makes it difficult to distinguish small changes in temperature of the cooking plate associated with the overlying cooking utensil.

It is known to provide what is referred to as a 'cool patch' of a glass-ceramic cooking plate within a heated area by an arrangement in which a discrete temperature sensing device surrounded by a thermally insulating enclosure is urged directly against a region of the lower surface of the cooking plate, to sense a change in temperature of the cooking plate produced by an overlying cooking utensil conducting heat back into the cooking plate in that area. Such a discrete temperature sensing device has been provided of capillary or electromechanical form, or of platinum resistance

temperature detector form, urged against the lower surface of the cooking plate, such as by spring loading means.

- 5 The provision of two separately formed temperature sensing devices in an electrical heating arrangement to fulfil the two requirements of monitoring cooking utensil temperature and cooking plate temperature is cumbersome and expensive and it is an object of the present  
10 invention to overcome or minimise this problem.

According to the present invention there is provided a temperature sensor assembly for an electrical heating arrangement, the arrangement comprising: a cooking plate  
15 having an upper surface for receiving a cooking utensil, and a lower surface; and an electric heater incorporating at least one electric heating element, the heater being supported in contact with the lower surface of the cooking plate, the temperature sensor assembly  
20 comprising: an elongate substantially planar substrate adapted to be located in the heater to extend at least partially across the heater from a peripheral region at least to a central region of the heater, the substrate having an upper surface adapted to be located in contact  
25 with, or in close proximity to, the lower surface of the cooking plate, and also having a lower surface, the upper

and/or lower surface or surfaces of the substrate being provided with at least one first temperature-sensitive electrical resistance element of film form at a first region of the substrate arranged to be proximate the peripheral region of the heater, the upper and/or lower surface or surfaces of the substrate being provided with at least one second temperature-sensitive electrical resistance element of film form at a second region of the substrate arranged to be proximate the central region of the heater, the first and second temperature-sensitive electrical resistance elements being provided with electrical connecting leads adapted for electrical connection to external control circuit means for the heater; at least one support member secured to the substrate and underlying at least the first region of the substrate; and thermal insulation means interposed between at least the lower surface of the substrate and the at least one support member substantially only at the first region of the substrate.

20

The thermal insulation means may be adapted to shield the at least one first temperature-sensitive electrical resistance element and a region of the cooking plate overlying the at least one first temperature-sensitive electrical resistance element, from direct thermal radiation from the at least one electric heating element.

25

The at least one first temperature-sensitive electrical resistance element may be arranged for monitoring temperature of the cooking utensil through the cooking plate.

5

The at least one second temperature-sensitive electrical resistance element may be arranged for monitoring temperature of the lower surface of the cooking plate.

10 At least two second temperature-sensitive electrical resistance elements may be provided on the upper and/or lower surfaces of the substrate.

The upper surface of the substrate may be adapted to be  
15 arranged at a distance of 0 mm to about 3.5 mm from the lower surface of the cooking plate.

The at least one support member may be arranged of channel form for receiving at least the first region of  
20 the substrate and the thermal insulation means. The thermal insulation means may be additionally interposed between the at least one support member and one or more side edges of the substrate at the first region of the substrate.

25

The thermal insulation means may comprise a thin layer of microporous thermal insulation material and/or alternative thermal insulation material. Suitable alternative thermal insulation material may be selected from vermiculite, perlite, mineral fibres, calcium silicate and inorganic foam, and mixtures thereof.

The thermal insulation means may be provided with a thickness thereof of from 1 mm to 10 mm, and preferably of from 2 mm to 4 mm, between the substrate and the at least one support member.

The first and second regions of the substrate may be provided of substantially the same width or the second region of the substrate may be provided of narrower width than the first region of the substrate.

A single support member may be arranged to underlie both the first and second regions of the substrate. In this case, the support member may be provided with one or more apertures at one or more regions thereof underlying the second region of the substrate, and/or may be provided with a coating of a material of high thermal emissivity, whereby exposure of the second region of the substrate to the effect of thermal radiation from the at least one electric heating element of the heater is maximised.

Alternatively, separate support members may be provided for the first and second regions of the substrate.

The at least one support member may comprise ceramic  
5 and/or metal.

Means may be provided to reduce or minimise thermal conduction along the substrate from the second region thereof to the first region thereof. Such means may  
10 comprise providing the substrate of small cross-sectional area, and/or providing the substrate with one or more apertures therethrough at a location intermediate the first and second regions thereof and/or providing the substrate of low thermal conductivity.

15

The substrate may comprise alumina, such as of 87 to 99 percent purity, steatite, forsterite, glass-ceramic, fused silica, celsian, aluminium titanate, cordierite, zirconia, alumina-zirconia blends, reaction bonded  
20 silicon nitride, or a thin metal strip such as of stainless steel, provided with a coating of a dielectric material.

The substrate may have a thickness from about 0.25 mm to  
25 about 3 mm and preferably from about 0.5 mm to about 1 mm.

The substrate and the support member may be adapted to extend outwardly from the heater at a periphery of the heater and to be secured to the heater at the periphery of the heater, such as by means of a mounting bracket, which may comprise stainless steel, plated mild steel or a high temperature resistant plastics material. The mounting bracket may be adapted and arranged to bias the substrate towards the lower surface of the cooking plate. For this purpose, the mounting bracket may be of cantilevered or spring-loaded form.

The electrical connecting leads for the first and second temperature-sensitive electrical resistance elements may be of film form on the substrate and extending to an end of the substrate arranged for location at a periphery of the heater. Such film-form electrical connecting leads may be provided with electrical terminal means, adapted for electrical connection to external electrically conducting leads leading to the external control circuit means.

The electrical connecting leads of film form may comprise substantially the same or similar material as the temperature-sensitive electrical resistance elements.

The temperature-sensitive electrical resistance elements may comprise platinum.

One or more electrically insulating or passivation layers may be provided on the upper and/or lower surface or surfaces of the substrate at least overlying the at least one first and/or the at least one second temperature-sensitive electrical resistance element or elements.

10 The substrate may be secured to the at least one support member by rivets, bolts or pins.

The cooking plate may comprise glass-ceramic material.

15 By means of the present invention, a compact, unitary and economically-manufactured temperature sensor assembly is provided. First and second film-form temperature-sensitive electrical resistance elements are provided on a single elongate substrate and adapted such that, when  
20 the assembly is installed in an electrical heating arrangement comprising an electric heater and an overlying cooking plate, the first temperature-sensitive electrical resistance element is arranged to monitor temperature of a cooking utensil on the cooking plate,  
25 while the second temperature-sensitive electrical resistance element is arranged to monitor temperature of



the cooking plate when exposed to radiation from a heating element in the heater. The first temperature-sensitive electrical resistance element is shielded by thermal insulation means from direct radiation from the heating element in the heater.

For a better understanding of the present invention and to show more clearly how it may be carried into effect, reference will now be made, by way of example, to the accompanying drawings in which:

Figure 1 is a plan view of an electrical heating arrangement provided with a temperature sensor assembly according to the present invention;

Figure 2 is a cross-sectional view of the arrangement of Figure 1;

Figure 3A is a perspective view of an embodiment of a temperature sensor assembly of the present invention for use in the arrangement of Figures 1 and 2;

Figure 3B is an exploded view of the temperature sensor assembly of Figure 3A;

Figure 3C is a detail of part of an alternative support member arrangement in the assembly of Figure 3A, showing an opening in a lower face thereof;

5 Figure 4 is a plan view of an alternative form of elongate substrate for use in the temperature sensor assembly of Figures 3A, 3B and 3C; and

Figure 5 is a side elevational view of an alternative  
10 form of temperature sensor assembly.

Referring to Figures 1 and 2, an electrical heating arrangement 2 comprises a glass-ceramic cooking plate 4 of well-known form, having an upper surface 6 for  
15 receiving a cooking utensil 8, such as a pan. A lower surface 10 of the cooking plate 4 has an electric heater 12 supported in contact therewith. The electric heater 12 comprises a dish-like support 14, such as of metal, in which is provided a base layer 16 of thermal and  
20 electrical insulation material, such as microporous thermal and electrical insulation material. A peripheral wall 18 of thermal insulation material is arranged to contact the lower surface 10 of the cooking plate 4.

25 At least one radiant electrical resistance heating element 20 is supported relative to the base layer 16.

The heating element or elements can comprise any of the well-known forms of heating element, such as wire, ribbon, foil or lamp forms, or combinations thereof. In particular, the heating element or elements 20 can be of corrugated ribbon form, supported edgewise on the base layer 16 of insulation material.

It is to be understood, however, that the present invention is not limited to a heater incorporating at least one radiant electrical resistance heating element 20. Instead of the radiant electrical resistance heating element or elements, at least one electrical induction heating element could be provided.

A terminal block 22 is provided at an edge region of the heater 12, for connecting the heating element or elements 20 to a power supply 24 by way of leads 26 and through a control means 28, which may be a microprocessor-based control arrangement.

20

A temperature sensor assembly 30 is provided in the heater 12 and as shown in detail in Figures 3A and 3B. The temperature sensor assembly 30 comprises a thin elongate substantially planar substrate 32, which is adapted to be located in the heater 12 to extend at least partially across the heater from a peripheral region 34

of the heater at least to a central region 36 of the heater. If required, the substrate 32 could be arranged to extend substantially completely across the heater. The substrate 32 has an upper surface 38 adapted to be located in contact with, or in close proximity to, the lower surface 10 of the cooking plate 4. Although the upper surface 38 of the substrate 32 is advantageously arranged to be located in contact with the lower surface 10 of the cooking plate 4, it may be located a small distance therefrom, for example up to about 3.5 mm therefrom.

The upper surface 38 of the substrate 32 is provided with a first temperature-sensitive electrical resistance element 40 of film form at a first region 42 of the substrate 32, which is arranged to be proximate the peripheral region 34 of the heater 12. The first temperature-sensitive electrical resistance element 40 suitably comprises platinum. If desired, more than one first temperature-sensitive electrical resistance element 40 may be provided.

Film-form electrical connecting leads 44, 46, suitably of substantially the same or similar material as the resistance element 40, are provided on the upper surface

~~38 of the substrate 32 and extending to terminal regions~~

48, 50 at an end 52 of the substrate 32.

Instead of or additional to the first temperature-

5 sensitive electrical resistance element 40 provided on  
the upper surface 38 of the substrate 32, a first  
temperature-sensitive electrical resistance element could  
be provided on a lower surface 66 of the substrate 32.

In this case, film-form electrical connecting leads

10 similar to connecting leads 44 and 46 would be provided  
extending along the lower surface 66 of the substrate 32  
from the resistance element to terminal regions at the  
end 52 of the substrate 32.

15 A second temperature-sensitive electrical resistance  
element 54 of film form, and suitably comprising  
platinum, is provided on the upper surface 38 of the  
substrate 32 at a second region 56 of the substrate,  
which is arranged to be proximate the central region 36  
20 of the heater 12. Film-form electrical connecting leads  
58, 60, suitably of substantially the same or similar  
material as the resistance element 54, are provided on  
the upper surface 38 of the substrate 32 and extending to  
terminal regions 62, 64 at the end 52 of the substrate

25 32.

Instead of or additional to the second temperature-sensitive electrical resistance element 54 provided on the upper surface 38 of the substrate 32, a second temperature-sensitive electrical resistance element 54A could be provided on a lower surface 66 of the substrate 32. In this case, film-form electrical connecting leads similar to connecting leads 58 and 60 would be provided extending along the lower surface 66 of the substrate 32 from the resistance element 54A to terminal regions at the end 52 of the substrate 32.

Two or more second temperature-sensitive electrical resistance elements 54, 54A, 54B may be provided at the second region 56 of the substrate 32, on the upper and/or lower surface or surfaces thereof, and their changes in electrical resistance with temperature arranged to be averaged.

The first and second electrical resistance elements 40, 54 are suitably arranged with a resistance value of between 50 and 1000 ohms and preferably between 100 and 500 ohms, at 0 degrees Celsius. They may be located relatively close together or quite widely separated on the substrate 32. They may be of thick film form and deposited on the substrate 32 by screen-printing.

One or more electrically insulating or passivation layers 68 may be provided on the upper 38 and/or lower 66 surfaces of the substrate, at least overlying the first 40 and/or second 54, 54A, 54B temperature-sensitive electrical resistance elements.

A support member 70, preferably of ceramic material such as steatite, cordierite or alumina, but optionally of metal, is secured to the substrate 32 such that it extends from the end 52 of the substrate 32 and underlies at least the first region 42 of the substrate 32. The support member 70 is of channel form, provided with an elongate recess 72 into which is received the first region 42 of the substrate 32.

15

Thermal insulation means 74 is provided in the recess 72 in the support member 70, interposed between the support member 70 and the lower surface 66 and side edges 76 of the first region 42 of the substrate 32. The thermal insulation means 74 is accordingly confined substantially to the first region 42 of the substrate 32 on the surface of which the first temperature-sensitive electrical resistance element 40 is provided.

25 The thermal insulation means 74 preferably comprises a thin layer of microporous thermal insulation material,

suitably of a thickness between 1 and 4 mm and preferably  
between 2 and 3 mm. Alternatively or additionally, the  
thermal insulation means 74 could comprise material  
selected from vermiculite, perlite, mineral fibres,  
5 calcium silicate and inorganic foam material, and  
mixtures thereof.

The substrate 32 is suitably secured to the support  
member 70 by one or more pins, bolts or rivets 78.

10.

A mounting bracket 80 is provided for the temperature  
sensor assembly. The mounting bracket 80 suitably  
comprises stainless steel or plated mild steel, but may  
optionally comprise a high temperature-withstanding  
15 plastics material. The mounting bracket 80 has a first  
portion 82 arranged with clip means 84 securely engaging  
recessed or rebated portions 86 of the support member 70.  
The mounting bracket 80 has a second portion 88 arranged  
to be secured to an outer rim of the dish-like support 14  
20 of the heater 12, by means of a threaded fastener 90  
passing through a hole 92 in the second portion 88 of the  
mounting bracket 80.

The temperature sensor assembly 30 is installed in the  
25 heater 12 such that it passes through an aperture or  
recess in the peripheral wall 18 of the heater and a rim



of the dish-like support 14. The end 52 of the substrate 32, with the terminal regions 48, 50, 62, 64, extends outwardly from the heater on the support member 70.

5 The mounting bracket 80 is suitably provided of cantilevered form from a single bent sheet or strip of metal and such that the substrate 32 is spring-biased towards the lower surface 10 of the cooking plate 4. The mounting bracket 80 may be constructed to incorporate  
10 alternative spring-loading means.

The first temperature-sensitive electrical resistance element 40 is arranged to be electrically connected to the control means 28 by way of electrical leads 94  
15 connected to the terminal regions 48, 50. The second temperature-sensitive electrical resistance element 54 is arranged to be electrically connected to the control means 28 by way of electrical leads 96 connected to the terminal regions 62, 64.

20

During operation of the electrical heating arrangement 2, the first region 42 of the substrate 32, with the first temperature-sensitive electrical resistance element 40 thereon, is shielded from direct thermal radiation from  
25 the heating element or elements 20 in the heater 12 by the thermal insulation means 74. A region 98 of the

glass-ceramic cooking plate 4 immediately overlying the first region 42 of the substrate 32 is also shielded from the direct thermal radiation from the heating element or elements 20. The first temperature-sensitive electrical resistance element 40 is therefore able to monitor the temperature of a cooking utensil 8 located on the upper surface 6 of the cooking plate 4, heat being conducted from the cooking utensil 8 into the region 98 of the cooking plate 4. Small changes in temperature of the cooking utensil 8 are therefore able to be monitored by the first temperature-sensitive electrical resistance element 40 and the resistance element 40 may therefore be used in association with the control means 28 to provide a closed loop autocook operation of the assembly and/or to detect when an important event, such as a boil-dry situation, occurs in the cooking utensil 8, accompanied by a small change in temperature.

The second temperature-sensitive electrical resistance element 54 on the second region 56 of the substrate 32 extends from the support member 70 and is not provided with the thermal insulation means 74. It is therefore able to monitor the temperature of the cavity in the heater in which it is located and particularly the temperature of the cooking plate 4 adjacent to it and which is substantially exposed to direct thermal

radiation from the heating element or elements 20. The close proximity of the second temperature-sensitive electrical resistance element 54 to the lower surface 10 of the cooking plate 4 enables the element 54 to accurately and sensitively monitor the temperature of the cooking plate 4.

It is advantageous to provide the second region 56 of the substrate 32 of as narrow a width as possible in order to economise on material of the substrate 32 and also to minimise shadowing thereby of the overlying region of the cooking plate 4 with respect to radiation from the heating element or elements 20. The substrate 32 may therefore be formed as shown in Figure 4, in which the second region 56 thereof on which the second temperature-sensitive electrical resistance element 54 is provided is of narrower width than the first region 42 thereof on which the first temperature-sensitive electrical resistance element 40 is provided. Such an arrangement is particularly preferred when the first temperature-sensitive electrical resistance element 40 is relatively wide, for example between about 8 mm and about 20 mm, thereby requiring a relatively wide first region 42 of the substrate 32. However, if the first resistance element 40 is relatively narrow, for example between about 3 mm and about 8 mm, a substrate 32 of

substantially constant width along its length may be satisfactorily employed.

Exposure of the second temperature-sensitive electrical  
5 resistant element 54 directly to the temperature of the  
surrounding cavity in the heater 12 in which it is  
located means that its own temperature will fluctuate  
during operation of the heater 12. This fluctuation may  
be transmitted along the substrate 32 and detected as  
10 thermal noise by the first temperature-sensitive  
electrical resistance element 40, which is undesirable.  
In order to reduce the magnitude of the heat flow,  
certain features can be incorporated into the design of  
the substrate 32.

15

Heat conduction is inversely proportional to the cross-  
section of material perpendicular to the direction of  
heat flow and thus the smaller the cross-sectional area  
of the substrate 32, the lower will be the heat flow, as  
20 given by the following equation:

$$q = TC_s \cdot A (T_H - T_C) / X_s$$

where :

$q$  = heat flow

$TC_s$  = thermal conductivity of substrate

25  $A$  = cross-sectional area of substrate

$T_H$  = temperature of second region 56 of substrate 32

$T_c$  = temperature of first region 42 of substrate 32

$X_s$  = length of substrate

A substrate 32 with the thinnest possible cross-section  
5 consistent with adequate mechanical properties is  
therefore preferred. In practice, a suitable thickness  
for the substrate 32 is from about 0.25 mm to about 3 mm  
and preferably from about 0.5 mm to about 1 mm.

10 Instead of or in addition to providing the substrate 32  
of as thin as possible cross-section, a portion 100 of  
the substrate 32 may be removed at a location between the  
first region 42 and the second region 56, thereby  
effectively reducing the cross-sectional area of the  
15 substrate 32 at this location.

An alternative method of reducing heat flow along the  
substrate 32 is to reduce or minimise the thermal  
conductivity of the substrate 32. A preferred material  
20 for the substrate 32 is alumina of 87 to 99 percent  
purity, which is relatively inexpensive, is readily  
available, has good mechanical strength, and has high  
electrical resistivity and dielectric strength. Although  
such material has a relatively high thermal conductivity  
25 of 20 to 30 W/m.K at room temperature, its thermal  
conductivity decreases markedly with increasing

temperature. For example, 95 percent alumina has a

thermal conductivity of about 23 W/m.K at a temperature of 25 degrees Celsius and this figure gradually reduces to about 6 W/m.K at a temperature of 1000 degrees

5 Celsius.

Other materials may be employed for the substrate 32, which have thermal conductivities of about 5 W/m.K or less. Examples of such materials are steatite,

10 forsterite, glass-ceramics (such as supplied by Corning under the trade name Macor), fused silica, celsian, aluminium titanate, cordierite, zirconia, alumina-zirconia blends, and low density reaction-bonded silicon nitride.

15

A metal, such as stainless steel, provided with a suitable high temperature-withstanding dielectric coating, could be considered for the substrate 32.

Although such a metal has quite high thermal conductivity  
20 (20 to 25 W/m.K), very thin sections could be adopted, thereby reducing heat flow therealong.

It may be advantageous to provide some mechanical support for the second region 56 of the substrate 32. For this  
25 purpose a support member 102 may be provided, which may be of channel form and which may form an integral

~~extension of the support member 70 or may be separate~~

therefrom. No thermal insulation means is provided in association with the support member 102, in contrast to the support member 70. The support member 102 preferably comprises a material of high thermal emissivity in order to ensure rapid thermal response of the second temperature-sensitive electrical resistance element 54 to changes in temperature of its surroundings. A support member 102 of thin ceramic material would be satisfactory, although a metal support member 102, such as of stainless steel, could be used if coated with a layer of high-emissivity material.

As shown in Figure 3C, one or more apertures 104 is or are advantageously provided in a base region of the support member 102, underlying the second temperature-sensitive electrical resistance element 54, to assist rapid response of such element 54 to changes in temperature of the surroundings.

As shown in Figure 5, it may be desirable to provide a spacer 106 or to form the passivation layer of greater thickness over the second temperature-sensitive electrical resistance element 40. While the principal reason for providing the passivation layer and/or the spacer 106 is to electrically decouple the resistance

elements 40, 54 from the cooking plate 4, its presence  
above the substrate 32 also effectively spaces the second  
temperature-sensitive electrical resistance element 54.  
(and consequently the first temperature-sensitive  
5 electrical resistance element 40) from the cooking plate  
4.

The provision of spacing means, either in the form of  
greater thickness or in the form of a spacer 106, can be  
10 used to adjust the response of one or both of the first  
and second temperature-sensitive electrical resistance  
elements 40, 54 and/or to improve electrical safety. The  
spacer 106 may have a thickness in the range from about  
0.25 mm to about 3.5 mm.



CLAIMS

1. A temperature sensor assembly for an electrical heating arrangement, the arrangement comprising: a  
5 cooking plate having an upper surface for receiving a cooking utensil, and a lower surface; and an electric heater incorporating at least one electric heating element, the heater being supported in contact with the lower surface of the cooking plate, the temperature  
10 sensor comprising: an elongate substantially planar substrate adapted to be located in the heater to extend at least partially across the heater from a peripheral region at least to a central region of the heater, the substrate having an upper surface adapted to be located  
15 in contact with, or in close proximity to, the lower surface of the cooking plate, and also a having a lower surface, the upper and/or lower surface or surfaces of the substrate being provided with at least one first temperature-sensitive electrical resistance element of  
20 film form at a first region of the substrate arranged to be proximate the peripheral region of the heater, the upper and/or lower surface or surfaces of the substrate being provided with at least one second temperature-sensitive electrical resistance element of film form at a  
25 second region of the substrate arranged to be proximate the central region of the heater, the first and second

temperature-sensitive electrical resistance elements

being provided with electrical connecting leads adapted for electrical connection to external control circuit means for the heater; at least one support member secured  
5 to the substrate and underlying at least the first region of the substrate; and thermal insulation means interposed between at least the lower surface of the substrate and the at least one support member substantially only at the first region of the substrate.

10

2. An assembly as claimed in claim 1, wherein the thermal insulation means is adapted to shield the at least one first temperature-sensitive electrical resistance element and a region of the cooking plate  
15 overlying the at least one first temperature-sensitive electrical resistance element, from direct thermal radiation from the at least one electric heating element.

3. An assembly as claimed in claim 1 or 2, wherein the  
20 at least one first temperature-sensitive electrical resistance element is arranged for monitoring temperature of the cooking utensil through the cooking plate.

4. An assembly as claimed in claim 1, 2 or 3, wherein  
25 the at least one second temperature-sensitive electrical

resistance element is arranged for monitoring temperature of the lower surface of the cooking plate.

5. An assembly as claimed in any preceding claim,  
5 wherein at least two second temperature-sensitive electrical resistance elements are provided on the upper and/or lower surfaces of the substrate.

6. An assembly as claimed in any preceding claim,  
10 wherein the upper surface of the substrate is adapted to be arranged at a distance of 0 mm to about 3.5 mm from the lower surface of the cooking plate.

7. An assembly as claimed in any preceding claim,  
15 wherein the at least one support member is arranged of channel form for receiving at least the first region of the substrate and the thermal insulation means.

8. An assembly as claimed in claim 7, wherein the  
20 thermal insulation means is additionally interposed between the at least one support member and one or more side edges of the substrate at the first region of the substrate.

25 9. An assembly as claimed in any preceding claim, wherein the thermal insulation means comprises a thin

layer of microporous thermal insulation material and/or alternative thermal insulation material.

10. An assembly as claimed in claim 9, wherein the  
5 alternative insulation material is selected from vermiculite, perlite, mineral fibres, calcium silicate and inorganic foam, and mixtures thereof.

11. An assembly as claimed in any preceding claim,  
10 wherein the thermal insulation means is provided with a thickness thereof of from 1 mm to 10 mm between the substrate and the at least one support member.

12. An assembly as claimed in claim 11, wherein the  
15 thermal insulation is provided with a thickness of from 2 mm to 4 mm.

13. An assembly as claimed in any preceding claim,  
wherein the first and second regions of the substrate are  
20 provided of substantially the same width.

14. An assembly as claimed in any of claims 1 to 12,  
wherein the second region of the substrate is provided of narrower width than the first region of the substrate.

~~15. An assembly as claimed in any preceding claim,~~

wherein a single support member is arranged to underlie both the first and second regions of the substrate.

5 16. An assembly as claimed in claim 15, wherein the support member is provided with one or more apertures at one or more regions thereof underlying the second region of the substrate and/or is provided with a coating of a material of high thermal emissivity, whereby exposure of  
10 the second region of the substrate to the effect of thermal radiation from the at least one electric heating element of the heater is maximised.

17. An assembly as claimed in any of claims 1 to 14,  
15 wherein separate support members are provided for the first and second regions of the substrate.

18. An assembly as claimed in any preceding claim,  
wherein the at least one support member comprises ceramic  
20 and/or metal.

19. An assembly as claimed in any preceding claim,  
wherein means is provided to reduce or minimise thermal conduction along the substrate from the second region  
25 thereof to the first region thereof.

20. An assembly as claimed in claim 19, wherein the means comprises providing the substrate of small cross-sectional area, and/or providing the substrate with one or more apertures therethrough at a location intermediate the first and second regions thereof and/or providing the substrate of low thermal conductivity.

21. An assembly as claimed in claim 20, wherein the substrate comprises alumina, steatite, forsterite, glass-ceramic, fused silica, celsian, aluminium titanate, cordierite, zirconia, alumina-zirconia blends, reaction bonded silicon nitride, or a thin metal strip provided with a coating of a dielectric material.

22. An assembly as claimed in claim 21, wherein the substrate comprises alumina of 87 to 99 percent purity.

23. An assembly as claimed in claim 21, wherein the substrate comprises stainless steel provided with the coating of dielectric material.

24. An assembly as claimed in any preceding claim, wherein the substrate has a thickness from about 0.25 mm to about 3 mm.

25. ~~An assembly as claimed in claim 24, wherein the~~  
substrate has a thickness from about 0.5 mm to about 1  
mm.

5 26. An assembly as claimed in any preceding claim,  
wherein the substrate and the support member are adapted  
to extend outwardly from the heater at a periphery of the  
heater and to be secured to the heater at the periphery  
of the heater.

10

27. An assembly as claimed in claim 26, wherein the  
support member is secured to the heater by means of a  
mounting bracket.

15 28. An assembly as claimed in claim 27, wherein the  
mounting bracket comprises stainless steel, plated mild  
steel or a high temperature resistant plastics material.

29. An assembly as claimed in claim 27 or 28, wherein  
20 the mounting bracket is adapted and arranged to bias the  
substrate towards the lower surface of the cooking plate.

30. An assembly as claimed in claim 29, wherein the  
mounting bracket is of cantilevered or spring-loaded  
25 form.

31. An assembly as claimed in any preceding claim,  
wherein the electrical connecting leads for the first and  
second temperature-sensitive electrical resistance  
elements are of film form on the substrate and extending  
5 to an end of the substrate arranged for location at a  
periphery of the heater.

32. An assembly as claimed in claim 31, wherein the  
film-form electrical connecting leads are provided with  
10 electrical terminal means, adapted for electrical  
connection to external electrically conducting leads  
leading to the external control circuit means.

33. An assembly as claimed in claim 31 or 32, wherein  
15 the electrical connecting leads of film form comprise  
substantially the same or similar material as the  
temperature-sensitive electrical resistance elements.

34. An assembly as claimed in any preceding claim,  
20 wherein the temperature-sensitive electrical resistance  
elements comprise platinum.

35. An assembly as claimed in any preceding claim,  
wherein one or more electrically insulating or  
25 passivation layers is or are provided on the upper and/or  
lower surface or surfaces of the substrate at least



~~overlying the at least one first and/or the at least one~~  
second temperature-sensitive electrical resistance  
element or elements.

5 36. An assembly as claimed in any preceding claim,  
wherein the substrate is secured to the at least one  
support member by rivets, bolts or pins.

37. An assembly as claimed in any preceding claim,  
10 wherein the cooking plate comprises glass-ceramic  
material.

38. A temperature sensor assembly substantially as  
hereinbefore described with reference to and as shown in  
15 the accompanying drawings.

39. An electrical heating arrangement provided with a  
temperature sensor assembly as claimed in any preceding  
claim.

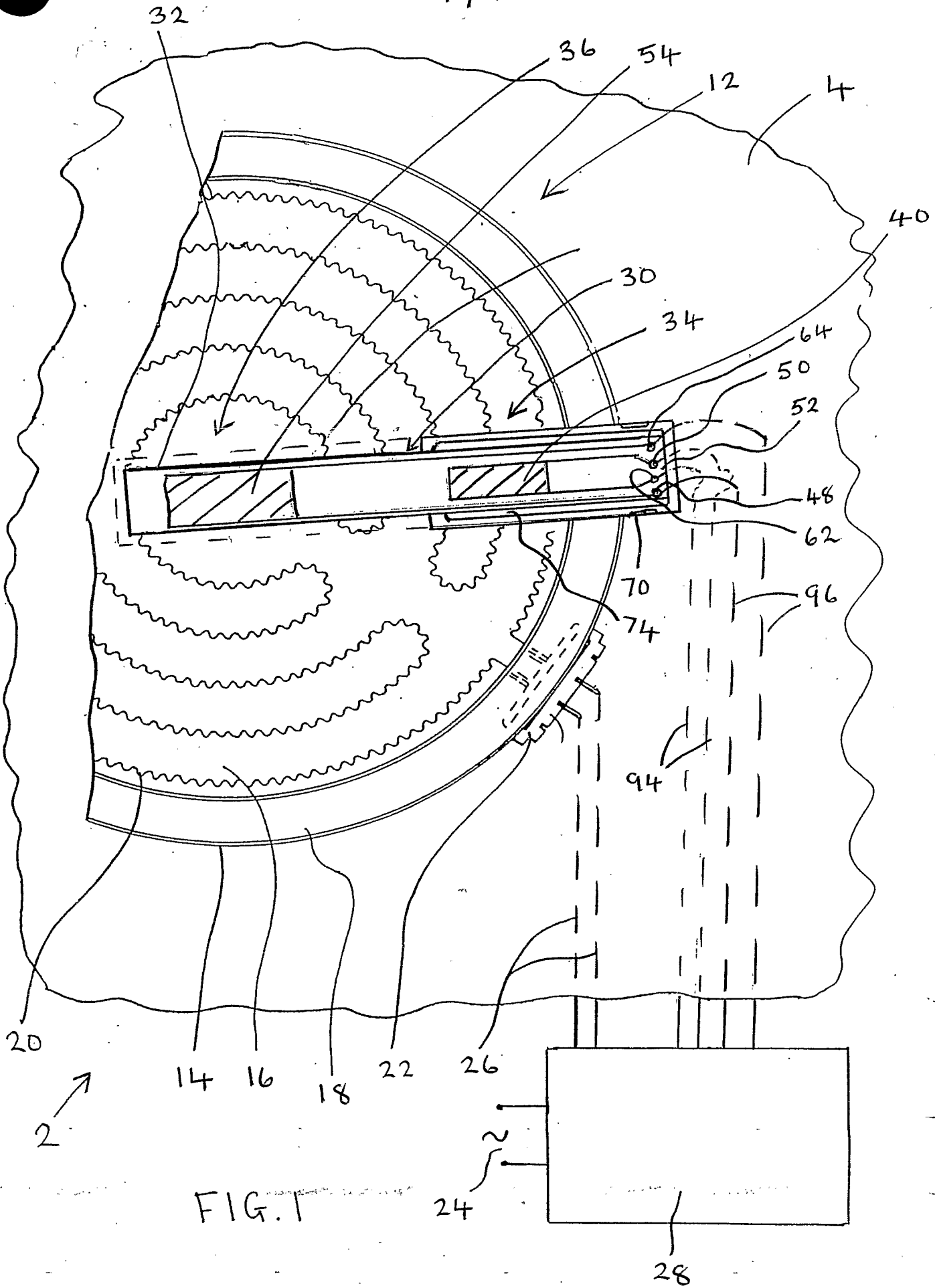
ABSTRACT

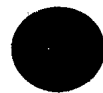
TEMPERATURE SENSOR ASSEMBLY

5 A temperature sensor assembly (30) is provided for an electrical heating arrangement (2). The arrangement (2) comprises: a cooking plate (4) having an upper surface (6) for receiving a cooking utensil (8), and a lower surface (10); and an electric heater (12) incorporating  
10 at least one electric heating element (20), the heater (12) being supported in contact with the lower surface (10) of the cooking plate (4). The temperature sensor assembly (30) comprises: an elongate substantially planar substrate (32) adapted to be located in the heater (12)  
15 to extend at least partially across the heater from a peripheral region (34) at least to a central region (36) of the heater (12), the substrate (32) having an upper surface (38) adapted to be located in contact with, or in close proximity to, the lower surface (10) of the cooking  
20 plate (4), and also having a lower surface (66). The upper and/or lower surface or surfaces (38, 66) of the substrate (32) is provided with at least one first temperature-sensitive electrical resistance element (40) of film form at a first region (42) of the substrate (32)  
25 arranged to be proximate the peripheral region (34) of the heater. The upper (38) and/or lower (66) surface or

~~surfaces of the substrate (32) is or are provided with at~~  
least one second temperature-sensitive electrical  
resistance element (54; 54A; 54B) of film form at a  
second region (56) of the substrate (32) arranged to be  
5 proximate the central region (36) of the heater. The  
first (40) and second (54; 54A; 54B) temperature-  
sensitive electrical resistance elements are provided  
with electrical connecting leads (44, 46, 58, 60) adapted  
for electrical connection to external control circuit  
10 means (28) for the heater (12). At least one support  
member (70; 102) is secured to the substrate (32) and  
underlying at least the first region (42) of the  
substrate (32) and thermal insulation means (74) is  
interposed between at least the lower surface (66) of the  
15 substrate (32) and the at least one support member (70)  
substantially only at the first region (42) of the  
substrate (32).

1/5





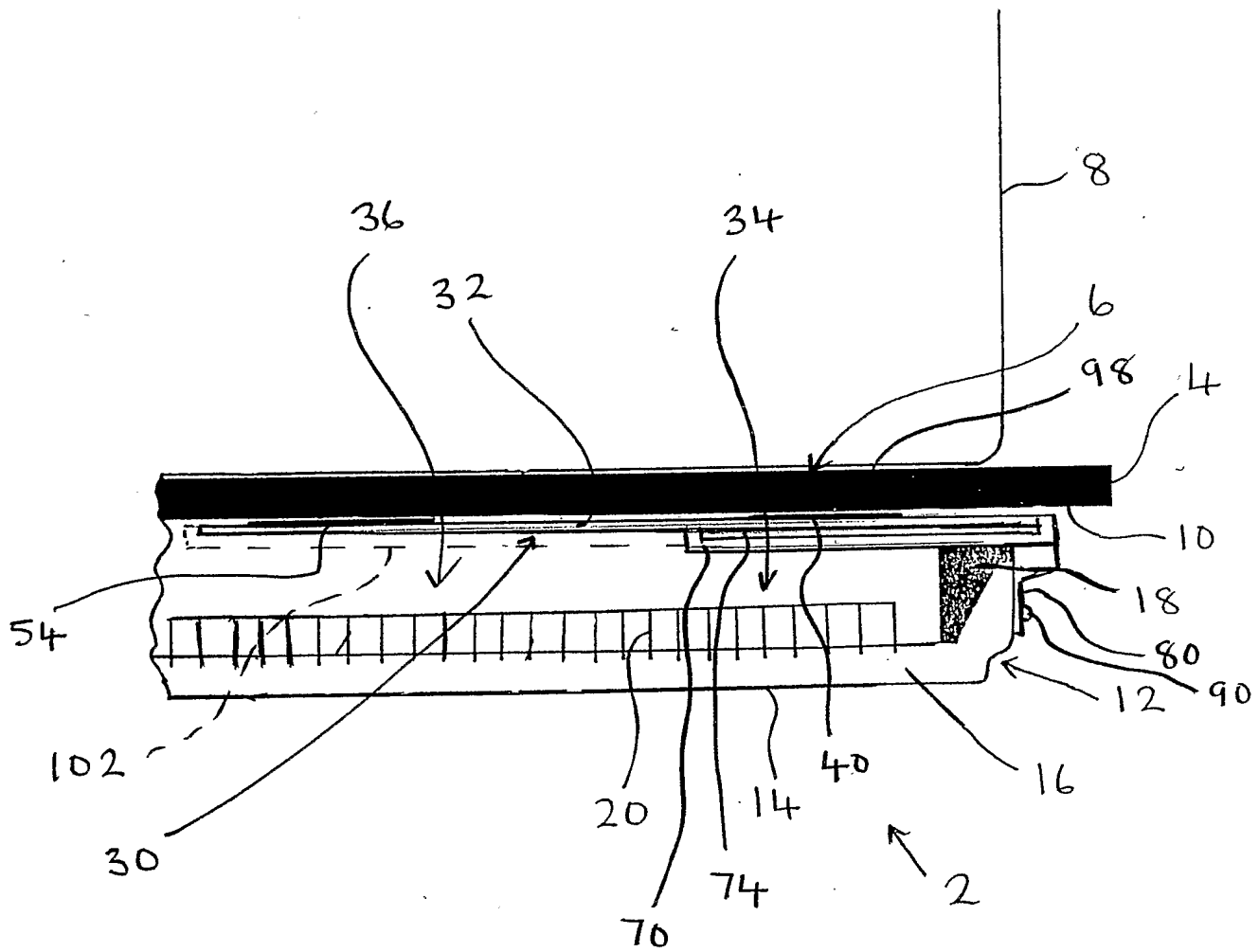
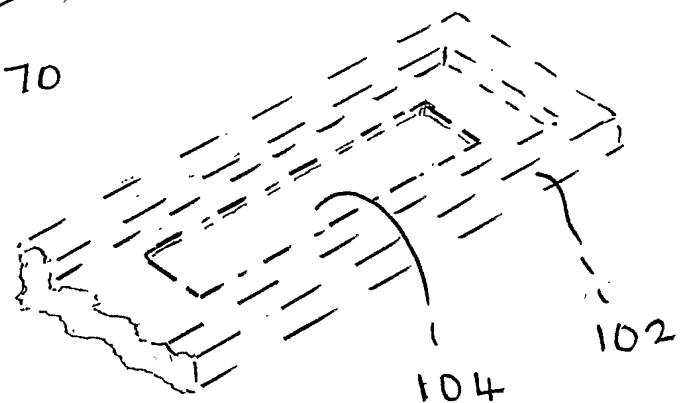
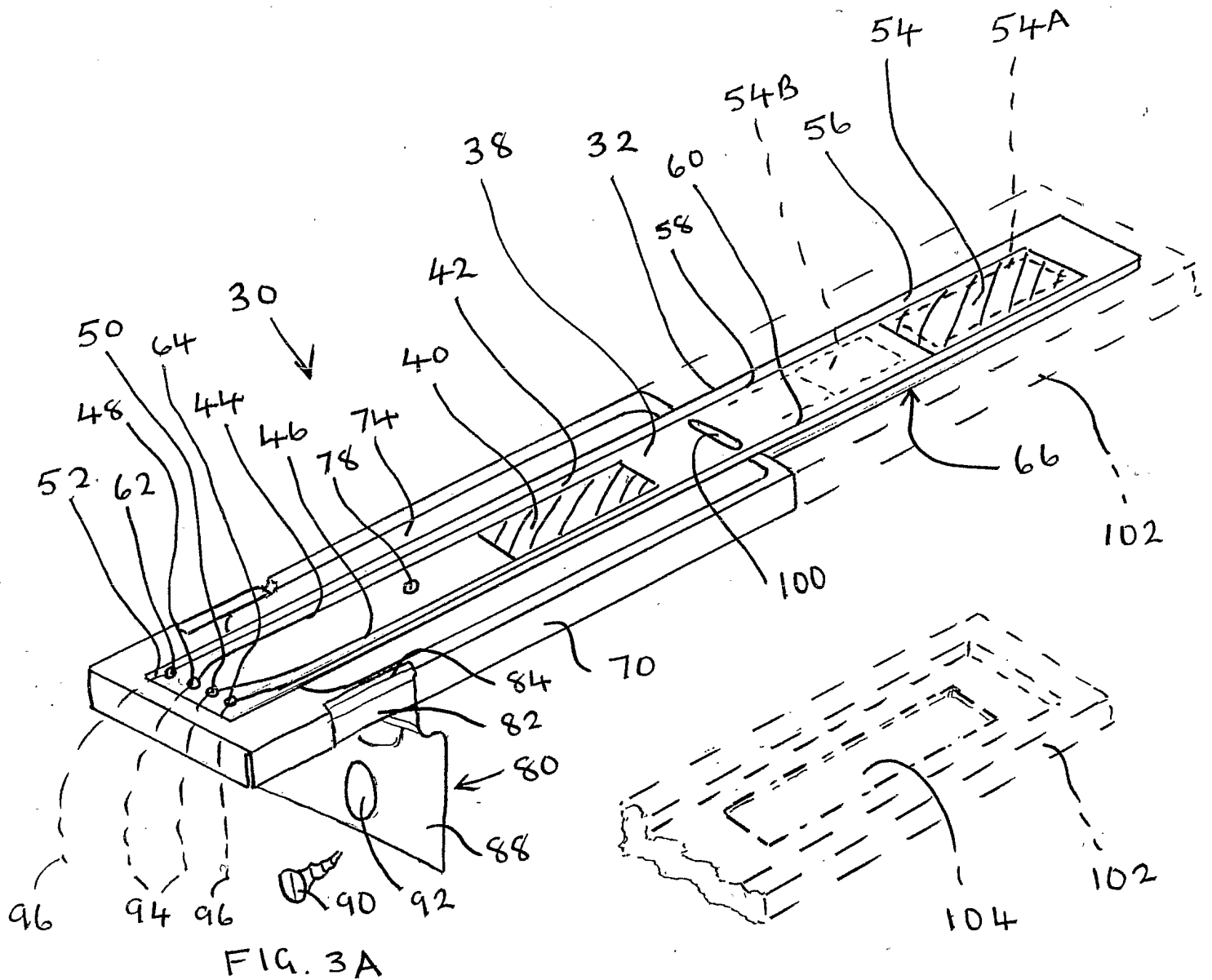


FIG. 2









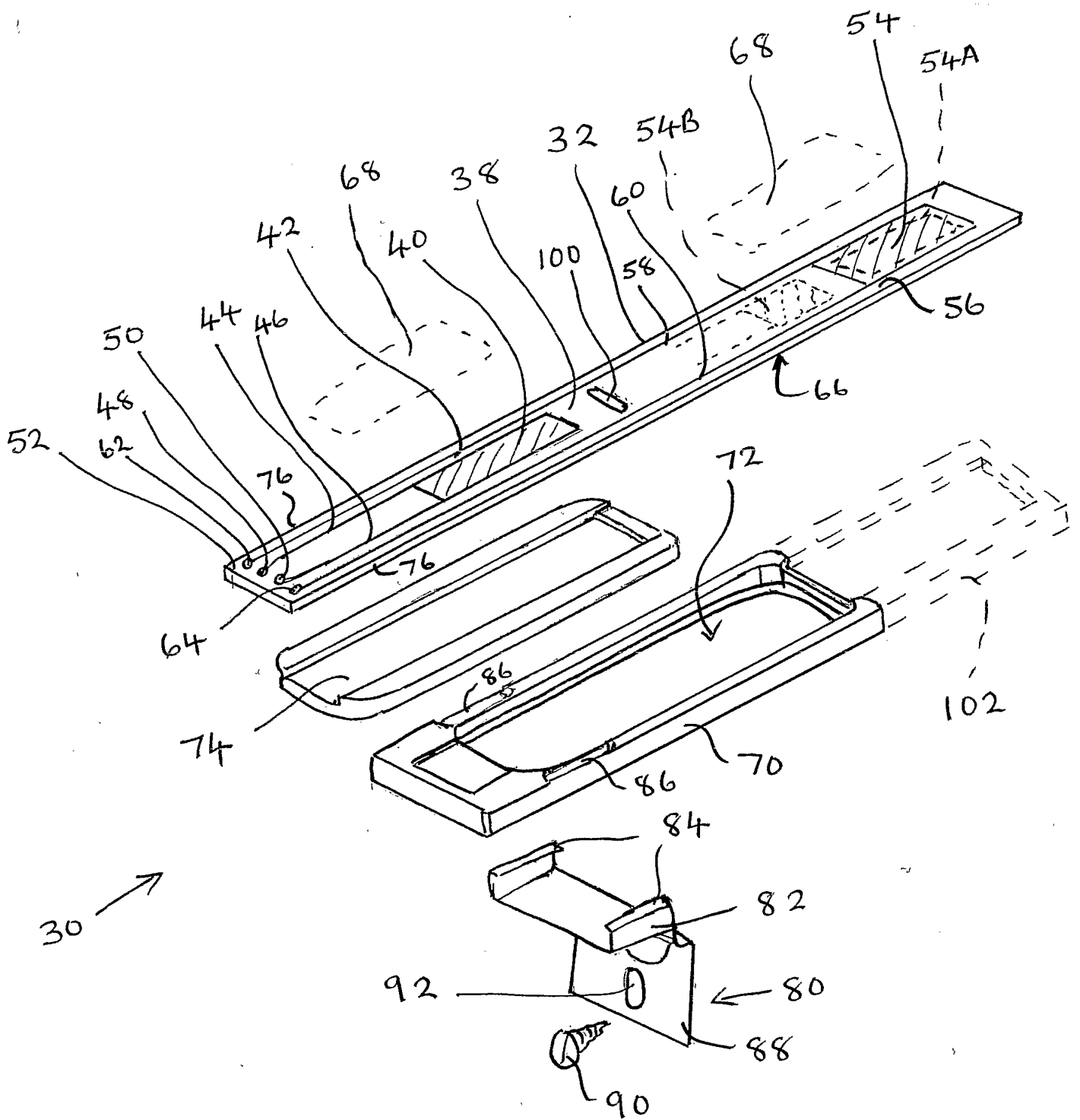


FIG. 3B



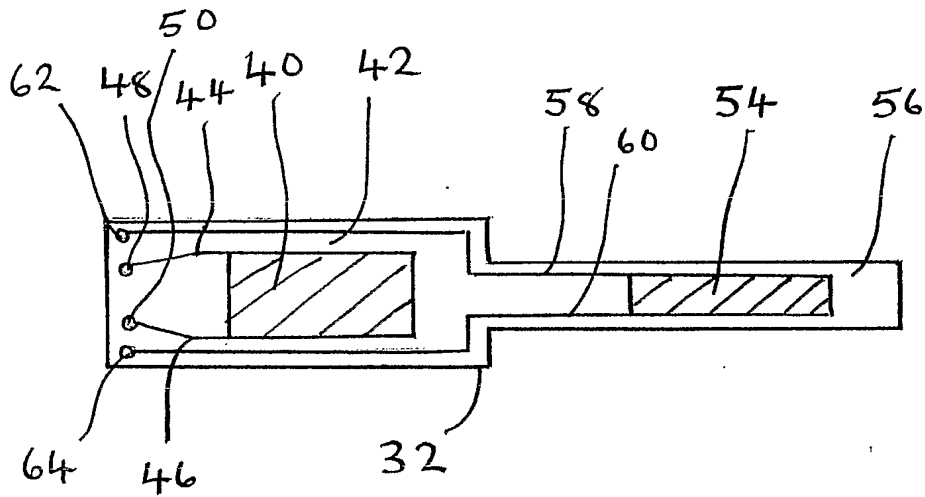


FIG. 4

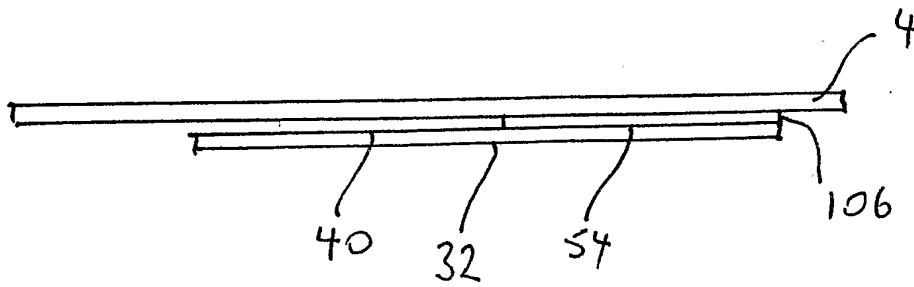


FIG. 5

